



Atty. Dkt. No. 039262-0165

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI et al

Title: PLASMA PROCESSING METHOD AND METHOD FOR
MANUFACTURING AN ELECTRONIC DEVICE

Appl. No.: 10/594,895

Filing Date: 11/07/2006

Examiner: Valerie N. Brown

Art Unit: 2829

Confirmation 8302

Number:

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

This communication is responsive to the Non-Final Office Action dated April 24, 2009, concerning the above-referenced patent application. Applicants have enclosed with this amendment a Petition for Extension of Time to make this response timely.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 3 of this document.

Please amend the application as follows:

10/26/2009 SZEWDIE1 00000028 10594895

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